

IN THE UNITED STATES PATENT APPLICATION

OF

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FOR

**LIQUID CRYSTAL DISPLAY DEVICE AND
FABRICATING METHOD THEREOF**

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AND FABRICATING METHOD THEREOF**

Cross Reference

[0001] This application claims the benefit of Korean Patent Application No. P00-87051, filed 30 December 2000, under 35 U.S.C. §119, the entirety of which is hereby incorporated by reference.

BACKGROUND OF THE INVENTION

Field of the Invention

[0002] This invention relates to a liquid crystal display device, and more particularly to a liquid crystal display device that is adaptable for use in large, high picture quality displays. The present invention also is directed to a method of fabricating such a liquid crystal display device.

Description of the Related Art

[0003] Generally, an active matrix liquid crystal display (LCD) uses thin film transistors (TFT's) as switching devices to produce a natural-looking moving picture. Since such LCDs can be made smaller than existing Cathode Ray Tube (CRT) displays, they have become widely used as monitors for devices such as personal computers, notebook computers, office equipment, cellular phones, and pagers.

[0004] Referring now to Fig. 1, which is a plan view showing a partial structure of a conventional liquid crystal display device, that LCD includes a TFT that is arranged extended from the intersection of a data line 4 and a gate line 2 to a portion of the data line 4. A pixel electrode 22 is connected to the drain electrode 10 of the TFT.

[0005] The TFT includes a gate electrode 6 that is connected to the gate line 2, a source electrode 8 that is connected to the data line 4, and the drain electrode 10. The source electrode 8 projects over the gate line 2 and is a part of the data line 4. The data line 4 is applied with a gap to the semiconductor layer 14 and 16. The drain electrode 10 and the pixel electrode 22 are connected together via a contact hole 20. The TFT also includes semiconductor layers 14 and 16 that define a channel 24 between the source electrode 8 and the drain electrode 10 when a gate voltage is applied to the gate electrode 6. Referring now to Fig. 2, the channel 24 typically has a length L of about 5 to 6 μ m and a width W of about 25 μ m. Referring now back to Figure 1, the channel is arranged along the data line 4 so as to increase the ON current. In operation, a TFT responds to a gate signal on the gate line 2 by selectively applying a data signal on the data line 4 to the pixel electrode 22.

[0006] In practice, an LCD includes a plurality of TFTs and pixel electrodes 22. Each pixel electrode 22 is positioned in a cell area defined between data lines 4 and gate lines 2. The pixel electrodes are comprised of a transparent conductive material. Each pixel electrode 22 can produce a potential difference with a common transparent electrode (not shown) provided on an upper substrate (not shown). By way of a potential difference, a liquid crystal positioned between the lower substrate 1 (not shown) and the upper substrate (not shown) is rotated due to dielectric anisotropy in the liquid crystal. Thus, a

molecular arrangement of the liquid crystal varies according to the voltage that is applied to each pixel electrode. As a result, the light transmission through the liquid crystal display varies pixel by pixel such that video information is displayed.

[0007] Fig. 3A to Fig. 3E are plan views and sectional views, taken along line a-a' of Fig. 1, which are useful for explaining a method of fabricating an LCD device as shown in Fig. 1. Referring first to Fig. 3A, the gate line 2 and the gate electrode 6 are provided on a substrate 1. The gate electrode 6 is formed by depositing a metal, such as aluminum (Al) or copper (Cu), such as by sputtering, and then etching to form the gate line and gate electrode.

[0008] Referring now to Fig. 3B, an active layer 14 and an ohmic contact layer 16 are then fabricated on a gate insulating film 12 formed on the gate line 2 and the gate electrode 6. The gate insulating film 12 is typically formed by depositing an insulating material, such as silicon nitride (SiN_x) or silicon oxide (SiO_x), by plasma enhanced chemical vapor deposition (PECVD). The active layer 14 is then fabricated from undoped amorphous silicon, while the ohmic contact layer 16 is formed from amorphous silicon that is heavily doped with an n-type or p-type impurity. The active layer 14 and the ohmic contact layer 16 are fabricated by deposition and subsequent patterning using chemical etching.

[0009] Referring now to Fig. 3C, the data line 4, the source electrode 8 and the drain electrode 10 are then provided on the gate insulating film 12. The data line 4 and the source and drain electrodes 8 and 10 are typically made from chrome (Cr) or molybdenum (Mo). The source electrode 8 projects over the gate line 2 and is a part of the data line 4. The data line 4 and the source and drain electrodes 8 and 10 are formed by first depositing

result can be a defective gate electrode and consequent reduced manufacturing throughput. Additionally, an LCD device having an extended gate electrode has a problem in that, since the TFT area extends along the data line to correspond to the lengthy gate electrode, the display area has a reduced aperture ratio.

[0013] In addition, as the overlapping area A of the gate electrode 6 and the data line 4 increases (see Fig. 1), the parasitic capacitance C_{gs} , which is proportional to the overlapping area A, increases. A large parasitic capacitance C_{gs} can cause flicker and a residual image, both of which reduce picture quality. Also, a large parasitic capacitance reduces the speed of response such that acceptable large-dimension LCDs are not possible.

SUMMARY OF THE INVENTION

[0014] Accordingly, it is an object of the present invention to provide a liquid crystal display device, and a fabricating method thereof, that are adaptive for high quality, large dimension liquid crystal display devices.

[0015] In order to achieve that and other objects of the invention, a liquid crystal display device according to one aspect of the present invention includes a gate electrode on a substrate; a gate insulating film on the substrate and over the gate electrode; a semiconductor layer on the gate insulating layer and over the gate electrode; source and drain electrodes formed on the semiconductor layer, wherein each of those electrodes includes a protrusion that extends toward the other electrode and over the semiconductor layer; a protective layer on the gate insulating film and over the source and drain electrodes; and a pixel electrode on the protective layer.

[0016] The semiconductor layer has a "E"-shaped channel formed along the source and drain electrodes. The semiconductor layer includes an active layer formed on the gate insulating film, and an ohmic contact layer formed on the active layer and provided with a "E"-shaped opening corresponding to the shape of the channel.

[0017] The channel beneficially has a width of more than 50 μm .

[0018] A method of fabricating a liquid crystal display device according to the principles of the present invention includes the steps of forming a gate electrode on a substrate; forming a gate insulating film on the substrate and over the gate electrode; forming a semiconductor layer on the gate insulating film and adjacent the gate electrode; forming source and drain electrodes on the semiconductor layer such that at least one protrusion projects from each electrode toward the other electrode, forming a protective layer on the gate insulating film and over the source and drain electrodes; and forming a pixel electrode on the protective layer. Beneficially, the semiconductor layer forms a TFT having a channel that follows the area between the source and drain electrodes. Furthermore, a "E" shaped channel is formed.

BRIEF DESCRIPTION OF THE DRAWINGS

[0019] The principles of the present invention will be apparent from the following detailed descriptions of an embodiment of the present invention, and with reference to the accompanying drawings, in which:

[0020] Fig. 1 is a plan view showing a partial structure of a conventional liquid crystal display device;

[0021] Fig. 2 is a plan view of the channel of Fig. 1;

[0022] Fig. 3A to Fig. 3E are plan views and sectional views, along line a-a, of the liquid crystal display device shown in Fig. 1;

[0023] Fig. 4 is a plan view showing a structure of a liquid crystal display device according to an embodiment of the present invention;

[0024] Fig. 5 is a plan view of the channel of Fig. 4; and

[0025] Fig. 6A to Fig. 6E are plan views and sectional views, along line b-b', of the liquid crystal display device shown in Fig. 4.

DETAILED DESCRIPTION OF THE PREFERRED EMBODIMENT

[0026] Refer now to Fig. 4 for a plan view of a partial structure of an LCD according to the principles of the present invention. On a lower substrate (element 31, shown in Figures 6A-6E) is a TFT arranged near an intersection of a data line 34 and a gate line 32. Also shown is a pixel electrode 52, which connects to a drain electrode 40 of the TFT.

[0027] The TFT includes a gate electrode 36 that is connected to the gate line 32, a source electrode 38 that is connected to the data line 34, and the drain electrode 40, which connects via a contact hole 50 to the pixel electrode 52. The TFT also includes semiconductor layers 44 and 46 that define a conductive channel 54 between the source electrode 38 and the drain electrode 40 when a gate voltage is applied to the gate electrode 36. As shown in Fig. 4, the source electrode 38 and the drain electrode 40 are each formed with at least one protrusion such that the channel 54 has the shape shown in Fig. 5.

[0028] Referring now to Figure 5, the channel 54 is fabricated with a width W of about 50 to 100 μm and with a length L of about 4 to 6 μm . The length L of the channel

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54 is beneficially equal to or less than that of the channel in the prior art (see Fig. 2) while its width W is beneficially greater (by more than 25 μm) than that of the prior art channel. In other words, the width W of the channel 54 is increased. Furthermore, by forming a channel as shown in Fig. 5, the overlapping area B between the source electrode 38 and the gate metal layers (32 and 36) can be reduced.

[0029] The TFT responds to gate signals on the gate line 32 so as to selectively apply a data signal on the data line 34 to the pixel electrode 52. Of course, in practice an LCD includes a plurality of TFTs and pixel electrodes. The pixel electrodes 52 are individually positioned in cells defined by data lines 34 and gate lines 32. The pixel electrodes are made from a transparent conductive material. each pixel electrode 52 can produce a potential difference with a common transparent electrode (not shown) on an upper substrate (not shown) when a data signal is applied to that electrode through a contact hole 50. A liquid crystal positioned between the lower substrate and the upper substrate is rotated due to its dielectric anisotropy by this potential difference. Thus, the liquid crystal selectively allows light from a light source to pass through the pixel electrode 52 to the upper substrate.

[0030] Fig. 6A to Fig. 6E are plan views and sectional views taken along line b-b' of Fig. 4. Those view are useful for explaining a method of fabricating an LCD device according to Fig. 4.

[0031] Referring first to Fig. 6A, the gate line 32 and the gate electrode 36 are formed on the substrate 31. Those elements are formed by depositing aluminum (Al) or copper (Cu), such as by sputtering, and then patterning the deposited layer to form the gate line 32 and the gate electrode 36.

depositing an insulating material on the gate insulating layer 42 in such a manner as to cover the exposed structure. The hole 50 is then formed by patterning the protective layer so as to expose the drain electrode 40. The protective layer 48 is beneficially comprised of an inorganic insulating material, such as silicon nitride (SiN_x) or silicon oxide (SiO_x), an acrylic organic compound or an organic insulating material having a small dielectric constant such as Teflon, BCB (benzocyclobutene), Cytop or PFCB (perfluorocyclobutane).

[0035] Referring now to Fig. 6E, a pixel electrode 52 is then formed on the protective layer 48. The pixel electrode 52 is formed by depositing a transparent conductive material, such as indium-tin-oxide (ITO), indium-zinc-oxide (IZO) or indium-tin-zinc-oxide (ITZO), on the protective layer 48 and into the contact hole 50. That transparent conductive material is then patterned to produce the pixel electrode 52. Significantly, the pixel electrode 52 is electrically connected, via the contact hole 50, to the drain electrode 40.

[0036] As described above, according to the principles of the present invention, protrusions from source and drain electrodes form a TFT channel into a "2" pattern. Accordingly, the width of the gate electrode is enlarged over that of a comparable prior art TFT. When a photo resist pattern for such a gate electrode is provided, the uniformity of the photo resist pattern can be improved, which reduces defects in the gate electrode, and thus improves manufacturing throughput. Also, a display according to the principles of the present invention can have an increased aperture ratio.

[0037] Furthermore, as the overlap of a gate electrode and a data line is decreased, a parasitic capacitance C_{gs} is decreased. Accordingly, flicker and residual

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